## DECLARATION AND POWER OF ATTORNEY FOR PATENT APPLICATION

As the below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below, next to my name.

I believe I am the original, first and sole inventor of the subject matter which is claimed and for which a United States Letter Patent is sought on the invention entitled "MICRO-NOZZLE, NANO-NOZZLE, MANUFACTURING METHODS THEREFOR, APPLICATIONS THEREFOR", the specification of which was filed on February 10, 2004 as United States Application No. 10/775,999.

I hereby state that I have reviewed and understand the contents of the above-identified Specification, including the Claims to Invention.

I hereby acknowledge the duty to disclose information, which is material to patentability as defined in 37 CFR 1.56.

Under 35 USC Section 119(e), I hereby claim the benefit of the earlier filing dates of United States Provisional Patent Application Serial No. 60/446,296 filed on February 10, 2003.

I hereby declare that all statements made herein of my own knowledge are true, and that all statements made herein on information and belief are believed to be true, and further that these statements were made with the knowledge that willful false statements and the like are punishable by fine or imprisonment, or both, under 18 U.S.C. 1001, and that willful false statements may jeopardize the validity of the application or any patent issued thereon.

## POWER OF ATTORNEY:

As named inventor, I hereby appoint Ralph J. Crispino, Reg. No. 46,144; Bosco B. Kim, Reg. No. 41,896, and Bradley Marazas, Reg. No. 51,997 to prosecute this application and transact all business in the Patent and Trademark Office connected herewith.

Send Correspondence to: Direct telephone calls to: Reveo, Inc. Ralph J. Crispino 85 Executive Blvd. (914) 345-9555 Elmsford, NY 10523 Sole inventor Sadeg M. Faris 24 Pocantico Kiver Rd, Residence: Pleasantville, NY 10570, USA S/A Post Office Address: US Citizenship

DECLARATION AND POWER OF ATTORNEY FOR PATENT APPLICATION
For: MICRO-NOZZLE, NANO-NOZZLE, MANUFACTURING METHODS THEREFOR, APPLICATIONS THEREFOR
Filed: February 10, 2004
Page 1 of 1